

Application/Control No.	Applicant(s)/Patent under Reexamination
09/846,254	KAMPE ET AL.
Examiner	Art Unit
ANDY HO	2194

SEARCHED						
Class	Subclass	Date	Examiner			
719	318	11/17/2008	A.H			

INTERFERENCE SEARCHED					
Subclass	Date	Examiner			
318	11/17/2008	A.H			
	Subclass	Subclass Date			

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
EAST, ACM: application, filter, event, define, setup, assign	11/17/2008	A.H
EAST, PALM, eDAN: inventors search	11/17/2008	A.H